

Docket No.: 50432-096

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of	:	Customer Number: 20277
Calvin T. GABRIEL, et al.	:	Confirmation Number: 7774
Application No.: 09/887,165	:	Group Art Unit: 1763
Filed: June 25, 2001	:	Allowed: September 21, 2004
	:	Examiner: George A. Goudreau
For: N-CONTAINING PLASMA ETCH PROCESS WITH REDUCED RESIST POISONING	:	

REQUEST FOR ACKNOWLEDGEMENT OF THE CITED ART

Mail Stop ISSUE FEE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

We are in receipt of the Notice of Allowance dated September 21, 2004.

In reviewing the file, it is noted that we have not received acknowledgement of the Information Disclosure Statement and cited art filed September 26, 2001. Enclosed are copies of the Information Disclosure Statement, PTO-1449 and stamped return postcard acknowledgement.

Applicant hereby respectfully requests that:

- (1) the appropriately acknowledged PTO-1449 be furnished to Applicant; and
- (2) the record be clarified to confirm that the cited art has been considered and made of record.

Respectfully submitted,

McDERMOTT WILL & EMERY LLP

Arthur J. Steiner

Registration No. 26,106

Please recognize our Customer No. 20277 as our correspondence address.

600 13th Street, N.W.
Washington, DC 20005-3096
Phone: 202.756.8000 AJS:tlg
Date: December 6, 2004

BEST AVAILABLE COPY

Applicant: Calvin T. GABRIEL, et al.

Docket No. 50432-096

Title/Mark: N-CONTAINING PLASMA ETCH PROCESS WITH REDUCED
RESIST POISONING

Serial/Reg./Patent No. 09/887,165

Date Sent: 09/26/01

☒ Hand Carried ☐ Fax ☐ Electronic

☐ Cert. of Mailing ☐ Express Mail No. _____

☐ Transmittal Letter

New Patent App ☐ Utility ☐ Design ☐ Cont. ☐ CIP ☐ Div. ☐ PCT ☐ CPA ☐ RCE ☐ Prov

☐ Other: _____

pages of Specification

pages of Claims

pages of Abstract

pages of Formal/Informal Drawings

☒ Information Disclosure Statement

1 Form PTO 1449

7 copies of cited references

☐ Preliminary Amendment

☐ Response to Missing Parts Notice

☐ Certified Copy of Priority Doc

☐ Claim for Convention Priority

☐ Verified Statement of Small Entity Status

☐ Transmittal of Issue Fee: Form PTO 85b

☐ Maintenance Fee for _____ years after grant

☐ Notice of Appeal ☐ Appeal Brief

☐ Recordation of _____ Patent _____ Trademark:

☐ Response/Amendment to Office Action of _____

☐ Other _____

Check for \$ ☐ Charge Deposit Acct. 500417 \$

Atty Init.

MVG

Trpr. #

5459

Secy. or PL Init.

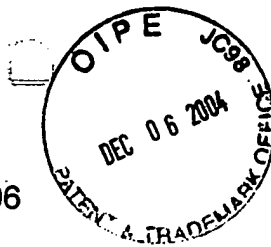
amz

CMS Descrip: _____

THE PATENT AND TRADEMARK OFFICE DATE STAMPED HEREON IS ACKNOWLEDGEMENT THAT THE ITEMS CHECKED ABOVE, WERE RECEIVED BY THE PTO ON THE DATE STAMPED.



Docket No.: 50432-096



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Calvin T. GABRIEL, et al.

Serial No.: 09/887,165

Group Art Unit: 1746

Filed: June 25, 2001

Examiner:

For: N-CONTAINING PLASMA ETCH PROCESS WITH REDUCED RESIST
POISONING

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
Washington, DC 20231

Dear Sir:


In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached form PTO-1449. It is respectfully requested that the documents be expressly considered during the prosecution of this application, and that the documents be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed within three months of the U.S. filing date OR before the mailing date of a first Office Action on the merits. No certification or fee is required.

Each reference cited is in the English language.

Respectfully submitted,

MCDERMOTT, WILL & EMERY


Matthew V. Grumbling
Registration No. 44,427

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INFORMATION DISCLOSURE
CITATION IN AN
APPLICATION

(PTO-1449)



ATTY. DOCKET NO.

50432-096

SERIAL NO.

09/887,165

APPLICANT

Calvin T. GABRIEL, et al.

FILING DATE

June 25, 2001

GROUP

1746**U.S. PATENT DOCUMENTS**

EXAMINER'S INITIALS	PATENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE
	6,103,456	8/2000	Többen et al.	430	317	
	4,804,636	2/1989	Grover, III et al.	437	52	
	6,025,116	2/2000	Grassmann	430	313	
	5,935,877	8/1999	Autryve	438	743	
	5,176,790	1/1993	Arleo et al.	156	643	
	6,130,166	10/2000	Yeh	438	710	
	5,908,319	6/1999	Xu et al.	438	725	

FOREIGN PATENT DOCUMENTS

EXAMINER'S INITIALS	PATENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						Yes	No

OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)

EXAMINER

DATE CONSIDERED

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.